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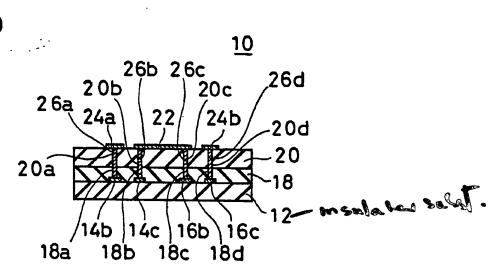
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- Multilayer ceramic substrate and its manufacturing method.
- The multilayer ceramic substrate includes an insulator substrate (12) consisting of, for example, ceramics. On a portion of one main surface of the insulator substrate, for example, circuit elements such as a capacitor, resistor and so on are formed. Moreover, at least on the other portion of the main surface, an insulator spacer (18) is formed. The insulator spacer forms a generally smooth surface in cooperation with the circuit elements. On the smooth surface, a separate insulator substrate (20) is formed. In the multilayer ceramic substrate, gaps are not formed on the side of circuit elements between the insulator substrate and separate insulator substrate by the insulator spacer. Besides, the thickness between such insulator substrates is generally constant.

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Multilayer Ceramic Substrate and Its Manufacturing Method

Field of the Invention

The present invention relates to a multilayer ceramic substrate and its manufacturing method, particularly, it relates to a multilayer ceramic substrate having circuit elements, for example, such as a capacitor, resistor and so on between insulator substrates and its manufacturing method.

Description of the Prior Art

Generally, with the development of small-sized electronic equipments, a=multilayer=high=density_ceramic_substrate=has=also=been=realized=As_such_multilayer_ceramic_substrate, for_example,=as_disclosed_in_Japanese=Ratent_Application=baid=Open=No_56204/1987,=a=multilayer=ceramic substrate having circuit elements such as a capacitor, resistor, inductor and so on is constituted by preparing a plurality of ceramic green sheets printed with thick films of dielectric paste, resistor paste, conductor paste etc., laminating and pressurizing the green sheets and firing the same.

In such conventional multilayer ceramic substrate, however, when each ceramic green sheet printed with paste is laminated and pressed, gaps are liable to form on the side of the portion where the pastes are printed, not only, causing the paste printed surface to delaminate easily during firing, but deteriorating the substrate smoothness as repeating lamination of the ceramic green sheet after painting the pastes, results in difficulty mounting the electronic elements on the fired substrate surface.

SUMMARY OF THE INVENTION

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It is, therefore, a primary object of the present invention to provide a multilayer ceramic substrate which is hardly delaminated during firing and has a good smoothness.

It is another object of the present invention to provide a method for manufacturing a multilayer ceramic substrate which is hardly delaminated during firing and has a good smoothness.

A multilayer ceramic substrate according to the present invention is the multilayer ceramic substrate including an insulator substrate, a circuit element formed on a portion of one main surface of the insulator substrate, an insulator spacer formed, at least, on the other portion of one main surface of the insulator substrate to form a generally smooth surface in cooperation with the circuit element, and a separate insulator substrate formed on the smooth surface.

A method for manufacturing a multilayer ceramic substrate according to the present invention is the method for manufacturing the multilayer ceramic substrate complsing, a process for preparing a ceramic green sheet formed into the insulator substrate by firing, a process for forming a circuit element paste layer formed into the circuit element by firing on a portion of one main surface of the ceramic green sheet, a process for forming an insulator material layer formed into the insulator spacer by firing, at least, on the other portion of one main surface of the ceramic green sheet so as to form a generally smooth surface in cooperation with the circuit element paste layer, a process for preparing a separate ceramic green sheet formed into the separate insulator substrate by firing, a process for forming a taminate by taminating the separate ceramic green sheet on the smooth surface, and a process for pressing and firing the taminate.

Gaps are not formed on the side of circuit element between the insulator substrates by the insulator spacer. Besides, the thickness between the insulator substrates is formed generally in constant by the insulator spacer.

According to the present invention, since the gaps are not formed on the side of circuit element, delamination between the layers during firing can be prevented. In addition, since the thickness between the insulator substrates is formed generally in constant, the smoothness of multilayer ceramic substrate after firing can be maintained. Accordingly, electronic elements can be easily mounted on the multilayer ceramic substrate and a multilayer high-density substrate can be more realized.

The above and other objects, features, aspects and advantages of the present invention will become more apparent form the following detailed description of the embodiments made in connection with the accompanying drawings.

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BRIEF DESCRIPTION OF THE DRAWINGS

Figs. 1A to 1D respectively show one embodiment of the present invention, in which Fig. 1A is a perspective view, Fig. 1B is an exploded perspective view, Fig. 1C is a sectional view taken along the line IC-IC of Fig. 1A and Fig. 1D is a sectional view taken along the line ID-ID of Fig. 1A.

Fig. 2A is an equivalent circuit diagram of the embodiment shown in Figs. 1A to 1D.

Figs. 3A to 3D respectively show one example of a process for manufacturing the embodiment shown in Figs. 1A to 1D, in which Figs. 3A, 3B and 3D are respective plan views and Fig. 3C is a sectional view taken along the line IIIC-IIIC of Fig. 3B.

Figs. 4A to 4C show another example of a process for manufacturing the embodiment shown in Figs. 1A to 1D, in which Figs. 4A and 4B are respective plan views and Fig. 4C is a sectional view taken along the line IVC-IVC of Fig. 4B.

Fig. 5 shows an example of, in particular, modified draw-out portion of an electrode of the embodiment shown in Figs. 1A to 1D, in which Fig. 5 corresponds to a sectional view taken along the line V-V of Fig. 1A.

Figs. 6A to 6C respectively show another embodiment of the present invention, in which Fig. 6A is a perspective view, Fig. 6B is a sectional view taken along the line VIB-VIB of Fig. 6A and Fig. 6C is a sectional view taken along the line VIC-VIC of Fig. 6A.

Figs. 7A to 7D respectively show an example of a process for manufacturing the embodiment shown in Figs. 6A to 6C, in which Figs. 7A, 7B and 7D are respective plan views and Fig. 7C is a sectional view taken along the line VIIC-VIIC of Fig. 7B.

DESCRIPTION OF THE PREFERRED EMBODIMENTS

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Figs. 1A to 1D respectively show one embodiment of the present invention, in which fig. 1A is a perspective view, Fig. 1B is its exploded perspective view, Fig. 1C is a sectional view taken along the line IC-IC of Fig. 1A and Fig. 1D is a sectional view taken along the line ID-ID of Fig. 1A. The multilayer ceramic substrate 10 includes an insulator substrate 12 consisting of ceramics.

On a portion of one main surface of the insulator substrate 12, as shown in Fig.1B, a capacitor 14 and resistor 16 as circuit elements are formed in spaced intervals.

The capacitor 14 includes, for example, a disc dielectric element 14a, on both surfaces of which electrodes 14b and 14c having draw-out portions are formed respectively. The electrode 14b, dielectric element 14a and electrode 14c of the capacitor 14 are formed on the insulator substrate 12 in this order. In this case, the draw-out portion of the electrode 14c is extended on one surface of the insulator substrate 12.

The resistor 16 includes, for example, a disc resistor element 16a, on both surfaces of which, also electrodes 16b and 16c having draw-out portions are formed respectively. The electrode 16b, resistor element 16a and electrode 16c are formed on the insulator substrate 12 in this order. In this case, the draw-out portion of the electrode 16c is also extended on one main surface of the insulator substrate 12.

Furthermore, on the other portion of one surface of the insulator substrate 12, an insulator spacer 18 is formed by the same ceramic material as the insulator substrate 12. In this case, the insulator spacer 18, as shown particularly in Fig. 1C, is formed on the side of the capacitor 14 and resistor 16 such that, the thickness is generally as same as the capacitor 14 and resistor 16 and its surface is generally flush with those of the capacitor 14 and resistor 16. In the insulator spacer 18, as particularly shown in Fig. 1D, through holes 18a, 18b, 18c and 18d are formed at the portions opposed to the draw-out portions of the electrodes 14b, 14c, 16b and 16c of the capacitor 14 and resistor 16.

Meanwhile, on the capacitor 14, resistor 16 and insulator spacer 18, a separate insulator substrate 20 is formed by the same ceramic material as the insulator substrate 12. In the insulator substrate 20, as shown in Fig. 1D, through holes 20a, 20b, 20c and 20d are formed respectively so as to communicate with the through holes 18a, 18b, 18c and 18d of the insulator spacer 18. Moreover, on the surface of the insulator substrate 20, a connecting electrode 22 is formed entirely between the surroundings of through holes 20b and 20c, and outer electrodes 24a and 24b are formed respectively around the through holes 20a and 20d.

The draw-out portion of the electrode 14c of the capacitor 14 and one end of the connecting electrode 22 are connected electrically by a conductor 26b in the through hole 18b of the insulator spacer 18 and the through hole 20b of the insulator substrate 20. Similarly, the electrode 16b of the resistor 16 is connected to the other end of the connecting electrode 22 by a conductor 26c in the through holes 18c and 20c. Thus, one end of the capacitor 14 and one end of the resistor 16 is connected electrically.

Furthermore, the electrode 14b of the capacitor 14 and the outer electrode 24a are connected by a conductor 26a in the through holes 18a and 20a, and the electrode 16c of the resistor 16 and the outer electrode 24b are connected by a conductor 26d in the through holes 18d and 20d.

Accordingly, the multilayer ceramic substrate 10, as shown in Fig. 2, shows an equivalent circuit configuration in which one capacitor 14 and one resistor 16 are connected in series.

Through the multilayer ceramic substrate 10 is manufactured by entirely firing the materials such as the capacitor 14 and resistor 16 pressed between a ceramic green sheet formed into the insulator substrate 12 and a separate ceramic green sheet formed into the separate insulator substrate 20, since a material formed into the insulator spacer 18 is also pressed between the ceramic green sheets which are formed into the insulator substrates 12 and 20, gaps are not formed on the side of the materials formed into circuit elements. Therefore, delamination between the layers hardly occur during firing. Besides, in the multilayer ceramic substrate 10, as the capacitor 14, resistor 16 and insulator spacer 18 are formed generally into a constant thickness between the insulator substrates 12 and 20, its surface is very smooth, thus the electronic elements can be easily mounted on the surface thereof.

In the multilayer ceramic substrate 10, for example, when an IC is mounted on the surface and a capacitor for restraining noises is connected between power sources and IC, if the capacitor 14 incorporated is used as the capacitor, a space for mounting the capacity can be eliminated. In addition, in the multilayer ceramic substrate 10, if the IC is mounted immediately above the capacitor 14 incorporated, the length of conductor patterns for connecting the capacitor 14 and IC can be shortened, thus it can be used in a high frequency circuit having such a connection without any problem.

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Next, an example, of manufacturing method of the multilayer ceramic substrate 10 will be described.

First, as shown in Fig. 3A, a ceramic green sheet 12' which is formed into the insulator substrate 12 by firing is prepared. As the ceramic green sheet 12', for example, as disclosed in Electronic Ceramics, Page 18 - 19, Mar., 1985, a mixture of ceramic powder composed of Al₂O₃, CaO, SiO₂, MgO, B₂O₃ and a very small amount of additives and a binder moulded into a sheet by a doctor blade process can be used. Characteristic deterioration of such a ceramic green sheet is minor, for example, when fired in a reducing atmosphere such as nitrogen, besides firing can be accomplished in a relatively low temperature of 900 - 1000° C.

Subsequently, on one main surface of the ceramic green sheet 12', conductive paste layers 14b' and 16b' which are formed into the electrode 14b of the capacitor 14 and the electrode 16b of the resistor 16 by firing, are formed respectively by printing and coating a conductive paste. As the conductive paste, compositions of base metals such as Cu, Ni, Fe etc. can be used since the ceramic green sheet 12' can be fired in the reducing atmosphere of 900 - 1000° C.

Meanwhile, on one main surface of the ceramic green sheet 12 including one end portion of the conductive paste layer 14b, a dielectric paste layer 14a which is formed into the dielectric element 14a by firing is formed by printing and coating a dielectric paste. As the dielectric paste, for example, nonreducing dielectric pastes of barium titanate group as disclosed in Japanese Patent Application Laid Open No. 56204/1987 can be used. Characteristic deterioration of such dielectric paste is minor even when fired in a reducing atmosphere by containing it in the ceramic green sheet.

Also, on one main surface of the ceramic green sheet 12 Including one end portion of the conductive paste layer 16b, a resistor paste layer 16a which is formed into the resistor element 16a by firing is formed by printing and coating a resistor paste. As the resistor paste, for example, nonreducing resistance compositions composed of resistance substances such as lanthanum boride and yttrium boride and nonreducing glass as disclosed in Japanese Patent Application Laid Open No. 27700/1980 or No. 29199/1980 can be used. When such resistor paste is used, characteristic deterioration is minor even when it is contained in the ceramic green sheet and fired in the reducing atmosphere.

Moreover, on one main surface of the ceramic green sheet 12' including the surface of dielectric paste layer 14a' and resistor paste layer 16a', conductive paste layers 14c' and 16c' which are formed into the electrodes 14c and 16c by firing are formed respectively by printing and coating a conductive paste.

Next, on one main surface of the ceramic green sheet 12, as shown in Figs. 3B and 3C, an insulator paste layer 18 as an insulator material layer which is formed into the insulator spacer 18 by firing, is formed by printing and coating an insulator paste composed of the same material as the ceramic green sheet 12.

The conductive paste layers, dielectric paste layer, resistor paste layer and insulator paste layer aforementioned are formed by using the thick-film technique and printing and coating respective pastes.

Furthermore, as shown in Fig. 3D, a separate ceramic green sheet 20' which is formed into the separate insulator substrate 20 by firing is prepared. A same material as the aforesaid ceramic green sheet 12' can be used for the ceramic green sheet 20'. On the surface of the ceramic green sheet 20', conductive

paste layers 22', 24a' and 24b' which are formed into the connecting electrode 22, outer electrodes 24a and 24b by firing are formed respectively by printing and coating the conductive paste.

Then, the ceramic green sheet 20' is laminated on the insulator paste layer 18' and so on. Before the lamination, through not shown in Figs. 3B to 3D, in the insulator paste layer 18' and ceramic green sheet 20', through holes 18a -18d and 20a - 20d are formed, in which the conductive paste which is formed into conductors 26a - 26d is filled.

By pressing and firing entirely, the multilayer ceramic substrate 10 shown in figs. 1A and 1D is obtained.

Next, another manufacturing method of the multilayer ceramic substrate 10 will be described.

In this method, it is different, in particular, in the point to form the insulator material layer which is formed into the insulator spacer 18 as follows, when compared to the aforesaid manufacturing process shown in Figs. 3A to 3D.

That is, in this method, the insulator material layer which is formed into the insulator spacer 18 is prepared as a ceramic green sheet 19. The ceramic green sheet 19 has the generally same thickness as the dielectric paste layer 14a' and resistor paste layer 18a' as shown in fig. 4A, and responsive to the dielectric paste layer 14a' and resistor paste layer 16a', through holes 19a and 19b generally as same size as those the former are formed therein.

As shown in Figs. 4B and 4C, the ceramic green sheet 19 is laminated on the ceramic green sheet 12'. Thereafter, as same as the method aforementioned, the ceramic green sheet 20' is laminated and pressed onto the ceramic green sheet 19 to obtain the multilayer ceramic substrate 10 by firing entirely.

In the embodiment aforementioned, the draw-out portion of the electrode 14c may be constructed as shown in Fig. 5, which corresponds to a sectional view taken along the line V-V of Fig. 1A. In the embodiment shown in Fig. 5, the draw-out portion of the electrode 14c of the capacitor 14 is formed on a portion of one main surface of the insulator substrate 20. The draw-out portion is connected to the connecting electrode 22 on the surface of dissulator=substrate=20=by the conductor 26b in the through hole 20b formed in the insulator substrate 20. Similarly, though not shown, the draw-out portion of the electrode 16c of the resistor 16 is also, following the aforesaid example of draw-out portion of the electrode 14c, formed on a portion of one main surface of substrate 20 and connected to the outer electrode 24b by the conductor 26d in the through hole 20d formed in the insulator substrate 20 as shown Fig. 1D.

Fig. 6A to 8c respectively shows another embodiment of the present invention, in which Fig. 6A is a perspective view, Fig. 6B is a sectional view taken along the line VIB-VIB of Fig. 6A and Fig. 6C is a sectional view taken along the line VIC-VIC of Fig. 6A. In the multilayer ceramic substrate 10 of this embodiment, when compared to the embodiment shown in Figs. 1A to 1D, in particular, the insulator spacer 18 is formed not only on the other portion of one main surface of the insulator substrate 12, but also on the capacitor 14 and resistor 16. In this case, the insulator spacer 18 is, in particular, so formed that its surface is generally smooth as shown in Fig. 1C. Therefore, the separate insulator substrate 20 is formed on the insulator spacer 18.

Also in the multilayer ceramic substrate=10,-similar=to=the_embodiment shown in Figs. 1A to 1D, one end of the capacitor 14 and resistor 16 are connected to the connecting electrode 22 and the other end of the capacitor 14 and resistor 16 are connected respectively to the outer electrodes 24a-and=24b-by_the conductors_26a=26d-in=the=through=holes=18a-=18d-and-20a-20d. Thus, the multilayer ceramic substrate 10 also shows the circuit configuration in which one capacitor 14 and one resistor 16 are connected in series.

Though the multilayer ceramic substrate 10 is also manufactured by entirely firing respective pressed materials such as the ceramic green sheets which are formed into the insulator substrates and so on, since gaps are not formed between the ceramic green sheets which are formed into the insulator substrates 12 and 20, delamination between the layers during firing are hardly occurred. Besides, since the capacitor 14 and resistor 16 are covered by the insulator spacer 18 and become smooth between the insulator substrates 12 and 20, namely, their thickness is constant therebetween, the entire multilayer ceramic substrate 10 also becomes smooth. Therefore, electronic elements can be easily mounted on the surface of the multilayer ceramic substrate 10.

Next, an example of manufacturing process of the multilayer ceramic substrate 10 shown in figs. 6A to 6C will be described.

First, as shown in Fig. 7A, on one main surface of the ceramic green-sheet-12 which is formed into the insulator substrate-12 by, firing, respective paste layers 14a - 14c and 16a - 16c which are formed into the capacitor 14 and resistor 16 by firing are formed. In this case, it is formed by the same process as those in the aforesaid respective manufacturing methods.

In this manufacturing method, as shown in Figs. 7B and 7C, in particular, on the ceramic green sheet

12', dielectric paste layer 14a' and resistor paste layer 16a', the insulator paste layer 18' as an insulator material layer which is formed into the insulator spacer 18 by firing, is formed by printing and coating an insulator paste composed of the same material as the ceramic green sheet 12'. As the insulator paste, preferably a material in which the leveling has been improved by adjusting the viscosity, vehicle compositions or squeegee pressure is used.

Thus, as shown in Fig. 7D, the separate ceramic green sheet 20' having conductive paste layers 22', 24a' and 24b' on its surface is laminated on the insulator paste layer 18'. Before the lamination, also in this embodiment, through holes 18a - 18d and 20a - 20d are formed respectively in the insulator paste layer 18' and ceramic green sheet 20', and a conductive paste which is formed into the conductors 26a -26b is filled in these through holes as shown Fig. 1D.

Finally, a multilayer ceramic substrate 10 shown in Figs. 6A to 6C is obtained by pressing and firing entirely.

In this manufacturing method, though an insulator material layer which is formed into the insulator spacer 18 is formed by an insulator paste, the insulator material layer may be formed by a ceramic green sheet. In this case, the ceramic green sheet has the thickness thicker than the dielectric paste layer 14a' and resistor paste layer 16a', and corresponding thereto, recesses having generally the same size as those in the dielectric paste layer 14a' and resistor paste layer 16a' are formed. The ceramic green sheet is laminated on the ceramic green sheet 12' and so on. Thereafter, as same as the method aforementioned, the ceramic green sheet 20' is laminated and pressed onto the ceramic green sheet and fired entirely, thereby the multilayer ceramic substrate 10 is obtained.

Example

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First, 200 samples were prepared respectively, as the embodiment of the present invention, by a method A shown in Figs. 3A to 3D, a method B shown in Figs. 4A to 4C and a method C shown in Figs. 7A to 7D.

In this case, as a ceramic green sheet, a low-temperature sintered ceramic green sheet having the thickness of 100 and composed of SiO₂, Al₂O₃, BaO, B₂O₃ and a binder was used. In addition, a nonreducing dielectric paste was used as a dielectric paste. As a resistor paste, a nonreducing resistor paste composed mainly of LaB₅ was used. A conductor paste of Cu group was used as a conductive paste. Then, respective paste layers were formed by a screen printing process. The entire paste layers and so on were pressed and fired at 950 °C in a nitrogen atmosphere.

Capacities and resistances measured for each sample by means of an LCR meter have shown the designed values.

As the conventional example, 200 samples were prepared by a method in which an insulator spacer is not formed as compared with the respective manufacturing methods A, B and C aforementioned.

For all samples, the delamination rate during firing and the surface smoothness after firing were checked. In this case, as to the surface smoothness, a maximum surface wavi ness was measured by a stylus-type surface roughness meter according to JIS-B0610 (high-range cut off value 0.8mm, reference length 25mm). Results are shown in the following Table:

TABLE

45 Sample by Sample by Sample by Sample of Method A Method B Method C Conventional Example Delamination Rate (%) 0.4 0.5 0.5 27.5 50 Maximum Surface Waviness (m) 21.5 20.2 19.5 295

From the table, according to the embodiment of the present invention, as compared with the conventional example, it is understood that the delamination rate during firing is reduced sharply and the surface smoothness after firing is improved considerably.

In respective embodiments aforementioned, though a multilayer ceramic substrate using materials which can be fired in a reducing atmosphere and its manufacturing process have been described, in the

present invention, it is not limited thereto, for example, the multilayer ceramic substrate can be prepared by materials which can be fired in an oxidizing atmosphere.

In the respective embodiments aforementioned, though a multilayer ceramic substrate incorporated with one capacitor and one resistor and its manufacturing method have been described as an example, it is not limited thereto, the present invention can also be applied in the multilayer ceramic substrates constructed otherwise.

While the present invention has been particularly described and shown, it is to be understood that it is for the purpose of illustration and example and not for limitation. The spirit and scope of the invention is therefore to be determined solely by the accompanying claims.

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Claims

- 1. A multilayer ceramic substrate comprising,
- 15 an insulator substrate:
 - a circuit element formed on a portion of one main surface of said insulator substrate;
 - an insulator spacer formed, at least, on the other portion of one main surface of sald insulator substrate and forming a generally smooth surface in cooperation with said circuit element; and
 - a separate insulator substrate formed on said smooth surface.
- 20 2. A multilayer ceramic substrate in accordance with claim 1,
 - wherein said insulator spacer is formed on the other portion of one main surface of said insulator substrate and has generally the same thickness as said circuit element, and
 - said separate insulator substrate is formed on said circuit element and insulator spacer.
 - 3 A multilayer ceramic substrate in accordance with claim 1,
- wherein said insulator spacer is formed on the other portion of one surface said insulator substrate and said circuit element such that its surface is generally smooth, and
 - said separate insulator substrate is formed on said insulator spacer.
 - 4. A method for manufacturing a multilayer ceramic substrate set forth in claim 1 comprising,
- a process for preparing a ceramic green sheet which is formed into said insulator substrate by firing;
 a=process-for-forming-a-circuit element paste layer which is formed into said circuit element by firing on a portion-of-one-main-surface-of-said-ceramic green-sheet;
 - a process for forming an insulator material layer which is formed into said insulator spacer by firing, at least, on the other portion of one main surface of said ceramic green sheet, so as to form a generally smooth surface in cooperation with said circuit element paste layer;
- a process for preparing a separate ceramic green sheet which is formed into said separate insulator substrate by firing;
 - a process for forming a laminate by laminating said separate ceramic green sheet on said smooth surface;
 - a process for pressing and firing said laminate.
- 5. A method for manufacturing a multilayer ceramic substrate in accordance with claim 4, wherein said process for forming said insulator material layer includes, a process for forming an insulator paste layer which is formed into said insulator spacer by firing, on the other portion of one main surface of said ceramic green sheet in the thickness generally as same as said circuit element paste layer, and said process for forming said laminate includes a process for laminating said separate ceramic green sheet on said circuit element paste layer and said insulator paste layer.
 - 6. A method for manufacturing a multilayer ceramic substrate in accordance with claim 5, wherein said process for forming said insulator paste layer includes a process for printing an insulator paste on the other portion of one main surface of said ceramic green sheet.
 - 7. A method for manufacturing a multilayer ceramic substrate in accordance with claim 4,
 - wherein said process for forming said insulator material layer includes,
 - a process for preparing an insulator ceramic green sheet which is formed into said insulator spacer by firing, and has the thickness generally as same as said circuit element paste layer and a through hole at the position opposed to said circuit element paste layer, and
 - a process for laminating said insulator ceramic green sheet on the other portion of one main surface of said ceramic green sheet, and furthermore
 - said process for forming said laminate includes a process for laminating said separate ceramic green sheet on said circuit element paste layer and said insulator ceramic green sheet.
 - 8. A method for manufacturing a multilayer ceramic substrate in accordance with claim 4,

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wherein said process for forming said insulator material layer includes a process for forming an insulator paste layer which is formed into said insulator spacer by firing, on the other portion of one main surface of said ceramic green sheet and said circuit element paste layer so as to make the surface generally smooth, and

- said process for forming said laminate includes a process for laminating said separate ceramic green sheet on said insulator paste layer.
 - 9. A method for manufacturing a multilayer ceramic substrate in accordance with claim 8, wherein said process for forming said insulator paste layer includes a process for printing an insulator paste on the other portion of one main surface of said ceramic green sheet and said circuit element paste layer.
 - 10. A method for manufacturing a multilayer ceramic substrate in accordance with claim 4, wherein said process for forming said insulator material layer includes a process for preparing an insulator ceramic green sheet which is formed into said insulator spacer by firing and thicker than the thickness of said circuit element paste layer, and opposing thereto, has a recess of the generally same size, and
- 15 a process for laminating said insulator ceramic green sheet on the other portion of one main surface of said ceramic green and said circuit element paste layer, and furthermore said process for forming said laminate includes a process laminating said separate ceramic green sheet on said insulator ceramic green sheet.

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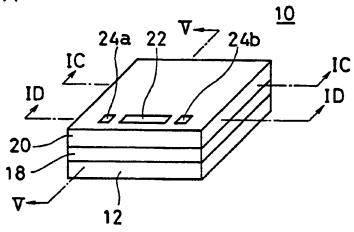
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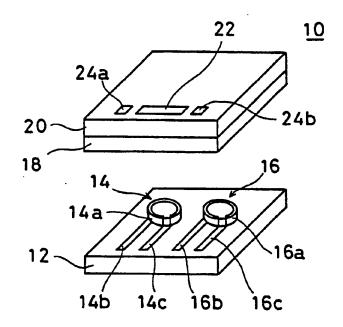
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F I G. 1 A



F I G.1B



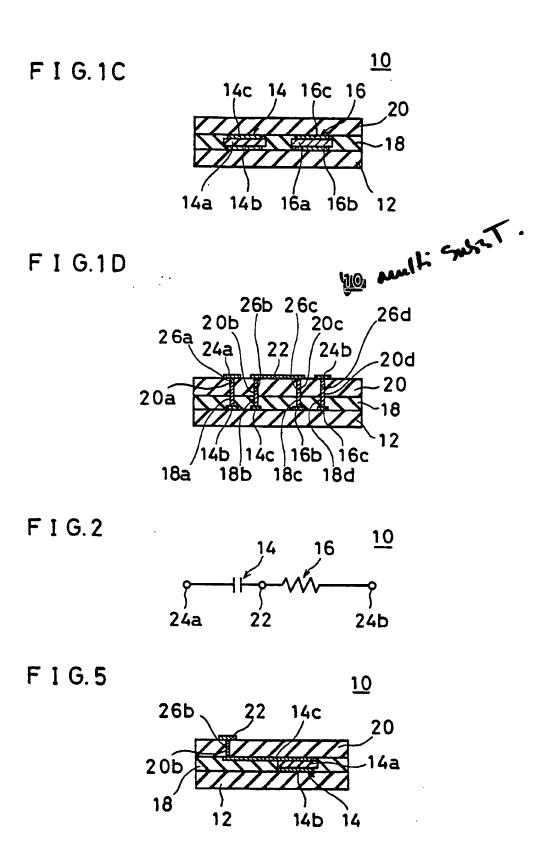
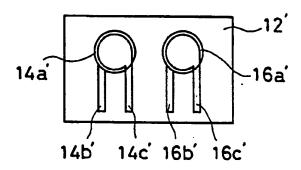
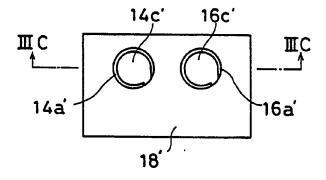


FIG.3A



F I G.3B

FIG.3C



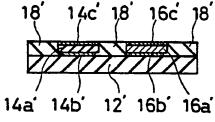
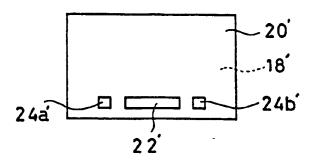
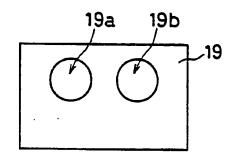


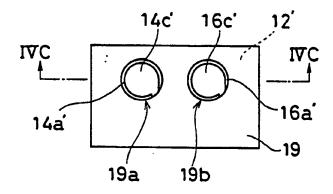
FIG.3D



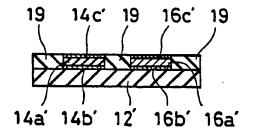
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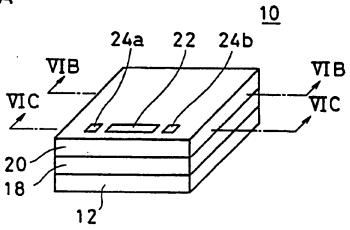
F I G. 4B



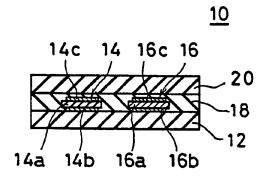
F I G. 4C



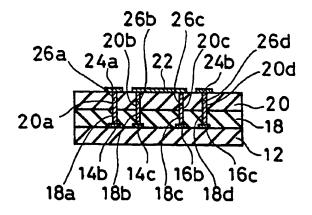
F I G. 6 A



F I G. 6B



F I G. 6C



F I G.7A

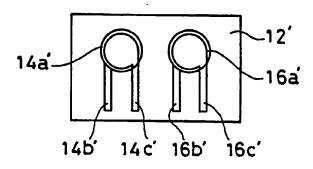
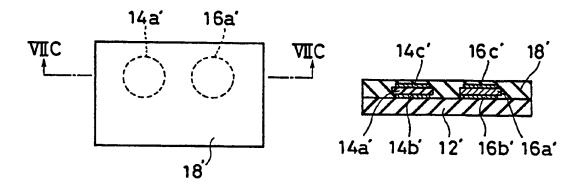
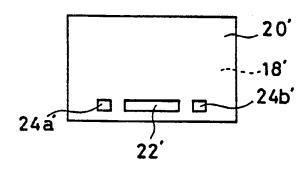


FIG.7B

FIG.7C



F I G.7D



EUROPEAN SEARCH REPORT

Application Number

EP 89 10 5911

		IDERED TO BE RELEVA	NT	
Category	Citation of document with of relevant p	indication, where appropriate, assages	Relevant to claim	CLASSIFICATION OF TH APPLICATION (Int. Cl.5)
X	EP-A-0 212 124 (IMACHINES) * Claim 1; figure 4	TERNATIONAL BUSINESS	1,2,4	H 01 L 23/538
A	EP-A-0 292 125 (FU * Page 7, lines 2-5	JJITSU LTD) 62 *	1-9	
A	WESCON TECHNICAL PApages 1-6, Califorr GOULD et al.: "Mult thick film packagin" * Page 3, column 2	ichip multilevel g"	4-9	
A	MACHINES)	TERNATIONAL BUSINESS 1, lines 13-30; page 15, line 20 *	1-3	
ľ	US-A-3 879 509 (G. * Claims 1,7,12; co	J. ELDERBAUM) lumn 5. line 51 -	4-9	
	column 6, line 34 *			TECHNICAL FIELDS SEARCHED (Int. CLS)
				H 01 L 23 C 04 B 51
	The present search report has b	een drawn up for all claims	_	
TUE	Place of search HAGUE	Date of completion of the search		Examiner
X : parti Y : parti doct A : tech	CATEGORY OF CITED DOCUME icutarly relevant if taken alone icutarly relevant if combined with and iment of the same category nological background written disclosure mediate document	E : earlier patent after the filing ther D : document cite L : document cite	ciple underlying the document, but public	shed on, or